	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
1	BRS	L1	1	(coat$6 or spray$4) with (substrate or wafer) with polymer and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and fluid with sens$4 and bubble with (sens$4 or detect$4) and valve and pressure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:12			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
2	BRS	L2	1	(coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) with polymer and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and fluid with sens$4 and bubble with (sens$4 or detect$4) and valve and pressure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:12			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
3	BRS	L3	1	(coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) with polymer and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and bubble with (sens$4 or detect$4) and valve and pressure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:14			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
4	BRS	L4	5	(coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) with polymer and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and bubble and valve and pressure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:21			

	Type	L. #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
5	BRS	L5	1	(coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) with polymer and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and bubble with releas$4 and valve and pressure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:21			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
6	BRS	L6	1	(coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) with polymer and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and bubble with (releas$4 or sens$4 or detect$4) and valve and pressure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:22			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
7	BRS	L7	27	(coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and bubble with (releas$4 or sens$4 or detect$4) and valve and pressure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:47			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
8	BRS	L8	0	((coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and bubble with (releas$4 or sens$4 or detect$4) and valve and pressure).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:48			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
9	BRS	L9	2	((coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve and pressure).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:49			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
10	BRS	L11	13	(427/240).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:54			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
11	BRS	L12	14	(118/52).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:56			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
12	BRS	L17	0	(118/690).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:57			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
13	BRS	L18	0	(118/691).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:57			
14	BRS	L10	2	((coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 15:59			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
15	BRS	L14	1	(118/712).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:01			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
16	BRS	L15	2	(118/688).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:01			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
17	BRS	L16	1	(118/689).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:02			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
18	BRS	L19	4	(118/692).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:02			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
19	BRS	L20	2	(118/693).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:02			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
20	BRS	L21	3	(118/694).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:03			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
21	BRS	L22	2	(118/683).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:03			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
22	BRS	L23	4	(118/684).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:04			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
23	BRS	L24	12	(118/320).ccls. and (coat$6 or spray$4 or spin adj coat$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin$4 or rotat$4) and (fluid or liquid) with (sens$4 or detect$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/25 16:05			